

Title (en)

METHOD AND DEVICE FOR PRODUCING A LOW-EMITTING LAYER SYSTEM

Title (de)

VERFAHREN UND VORRICHTUNG ZUR HERSTELLUNG EINES NIEDRIGEMITTIERENDEN SCHICHTSYSTEMS

Title (fr)

PROCÉDÉ ET DISPOSITIF DE PRODUCTION D'UN SYSTÈME DE COUCHES À FAIBLE ÉMISSIVITÉ

Publication

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Application

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Abstract (en)

[origin: WO2013026817A1] The invention, which relates to a method for producing a low-emitting layer system, comprising the steps of forming at least one low-emitting layer on at least one side of the substrate by means of deposition and subsequent brief tempering of a deposited low-emitting layer by means of electromagnetic radiation, avoiding an immediate heating up of the substrate, and to a device for performing the method, addresses the problem of improving the optical and thermal properties of a low-emitting layer system without cost-intensive tempering of the entire substrate while maintaining the processability of the low-e coated substrate.

IPC 8 full level

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